



03-03-05

Zhu  
AF  
1765Corres. and Mail  
**BOX AF****RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 1765****PATENT**  
Attorney Docket No. 00044X215193  
LVM Reference No. 215193**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

DO NOT ENTER

In re Application of:

Chou et al.

Application No. 10/043,534

Art Unit: 1765

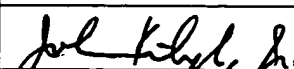
Examiner: Lan Vinh

Filed: January 10, 2002

For: AMMONIUM OXALATE-  
CONTAINING POLISHING SYSTEM  
AND METHOD3/11/05  
LV**RESPONSE TO OFFICE ACTION**Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated October 4, 2004, please enter the following amendments and consider the following remarks.

<b>CERTIFICATE OF MAILING UNDER 37 CFR 1.10</b>			
I hereby certify that this Response to Office Action and all accompanying documents are being deposited with the United States Postal Service on March 1, 2005, in an envelope as "EXPRESS MAIL POST OFFICE TO ADDRESSEE" service under 37 CFR 1.10, Mailing Label Number EV 419251752 US, addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.			
Name (Print/Type)	John Kilyk, Jr.		
Signature		Date	March 1, 2005